
**Super-Hydrophobic PDMS Surface with Ultra-Low Adhesive Force**

*Mehua Jin*,¹²,³ *Xinjian Feng*,² *Jin Zhai*,² *Kilwon Cho*,³ *Lin Feng,*¹,² *Lei Jiang*²

¹ Department of Chemistry, Tsinghua University, Beijing 100084, P. R. China, E-mail: fl@mail.tsinghua.edu.cn

² Institute of Chemistry, Chinese Academy of Sciences, Beijing 100080, P. R. China, E-mail: jianglei@iccas.ac.cn

³ Department of Chemical Engineering, Pohang University of Science and Technology, Pohang 790-784, Korea
Figure S1. The schematic illustration of the laser etching process on the surface of PDMS.

Figure S2. The schematic illustration of replicating process on PC nanopillars.